

UCSF May Submit 1 Application

Internal Deadline: 11:59 PM, Tuesday, July 5th, 2022

PLEASE FORWARD THIS ANNOUNCEMENT TO ALL APPROPRIATE FACULTY AND RESEARCH ADMINISTRATORS

WHAT: CDC NIOSH Occupational Safety and Health Education and Research Centers (T42)
(<https://grants.nih.gov/grants/guide/rfa-files/RFA-OH-22-001.html>)

REQUEST FOR APPLICATIONS NUMBER: RFA-OH-22-001

PURPOSE:

- To provide high-quality interdisciplinary graduate and post-graduate training, research training, continuing education, and outreach in the core occupational safety and health disciplines of industrial hygiene, occupational health nursing, occupational medicine, and occupational safety, as well as allied disciplines.

ELIGIBILITY:

- Any individual(s) with the skills, knowledge, and resources necessary to carry out the proposed research as the Program Director(s)/Principal Investigator(s) (PD(s)/PI(s)) is invited to work with his/her organization to develop an application for support. Individuals from underrepresented racial and ethnic groups as well as individuals with disabilities are always encouraged to apply.

BUDGET AND PROJECT PERIOD:

- Award Budget: up to \$1,800,000 total costs per year
 - Graduate Programs may request up to \$150,000 total costs per year.
 - Occupational Medicine Residency Programs may request up to \$250,000 total costs per year.
 - UCSF indirect cost policy will apply except for non-federal entities.
- Project Period: 3 years

NUMBER OF APPLICATIONS UCSF MAY SUBMIT: 1

APPLICATION TYPES ALLOWED: New, Renewal, Resubmission, Revision

CURRENTLY FUNDED INSTITUTIONS: [17](#)

DUE DATES:

- **Internal: 11:59 PM, Tuesday, July 5th, 2022.** If multiple groups submit an LOI, an additional pre-application will be due Tuesday, July 26th, 2022.
- **PIs submit directly to the LSP; RMS does not get involved unless and until you are nominated.**
- Sponsor: Monday, October 24th, 2022.

Submit the attached Letter of Intent (LOI) by **11:59 PM, July 5th**, to: limitedsubmissions@ucsf.edu

To qualify for UCSF Limited Submission Program opportunities, applicants must have a paid UCSF appointment either at the time of application or anticipated by the time of award.

The LSP is a selection process, not an award process. As the LSP is under significant time constraints, all reviewer feedback is optional. We encourage you to seek other avenues for proposal feedback.

For information on all current LSOs, please visit: <http://rdo.ucsf.edu/limited-submission-program-lsp>

Sent by Avity Norman on behalf of the Limited Submission Program (LSP) within the Research Development Office (RDO).